

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Branco et al.

Serial No.: 09/617,454

Filed: July 17, 2000

Title: Method for Cleaning Plasma Etch  
Chamber Structures

Attorney Docket No.: CY-0015

Group Art Unit: 1746

Examiner: Markoff, A.

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## RESPONSE TO OFFICE ACTION

5 Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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A. Introductory Comments

The following is submitted in response to the Notice of Non-Compliant Amendment  
dated June 2, 2004, and is currently due July 2, 2004.

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37 C.F.R. §1.8

I hereby certify that this correspondence is being

☒ transmitted via facsimile to the United States Patent and Trademark Office to fax number: 1-703-872-9306

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Date of Transmittal: JUNE 17, 2004☐ deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents,  
P.O. Box 1450, Alexandria, VA 22313-1450.

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Date of Deposit: \_\_\_\_\_

Typed/Printed Name: Bradley T. SakoSignature: 

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